

FORM PTO 1449 (modified)

ATTY DOCKET NO.
862.C1883APPLICATION NO.
09/542,460U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

Submitted to the PTO: August 17, 2000

APPLICANTS
TATSURO YAMAZAKI, ET AL.FILING DATE
April 4, 2000GROUP
Unassigned

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4,904,895	02/1990	Tsukamoto, et al.	313	336	
	5,066,883	11/1991	Yoshioka, et al.	313	309	
	5,569,974	10/1996	Morikawa, et al.	313	310	
	5,682,085	10/1997	Suzuki, et al.	315	169.1	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
I.L	4-28137	01/1992	Japan			Abstract
↓	3-55738	03/1991	Japan			Abstract
↓	64-31332	02/1989	Japan			Abstract
I.L	2-257551	10/1990	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

I.L	M.I. Elinson, et al., "The Emission of Hot Electrons and the Field Emission of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, pp. 1290-1296 (July 1965).
↓	G. Dittmer, 'Electrical Conduction and Electron Emission of Discontinuous Thin Films', Thin Solid Films, 9, pp. 317-328 (1972).
↓	H. Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films", pp. 22-29 (January 26, 1983).
I.L	M. Hartwell, et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", International Electron Devices Meeting, pp. 519-521 (1975).

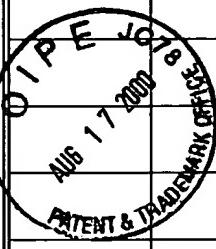
EXAMINER

LAI, LIN-YI

DATE CONSIDERED

8/7/04

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Submitted to the PTO: August 17, 2000				ATTY DOCKET NO. 862.C1883		APPLICATION NO. 09/542,460			
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<i>L.L</i>		W.P. Dyke, et al., "Field Emission", Advances in Electronics and Electron Physics, Vol. VIII, pp. 89-185 (1956).							
<i>L.L</i>		C.A. Spindt, et al., "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones", Journal of Applied Physics, Vol. 47, No. 12, pp. 5248-5263 (December 1976).							
<i>L.L</i>		C.A. Mead, "Operation of Tunnel-Emission Devices", Journal of Applied Physics, Vol. 32, No. 4, pp. 646-652 (April 1961).							
<i>L.L</i>		R. Meyer, "Recent Development on "Microtips" Display at LETI", Technical Digest of IVMC 91, pp. 6-9 (1991).							

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